## IN THE CLAIMS:

Please amend the claims as follows:

Claim 1 (Original): A laser processing method for irradiating a substrate having a front face formed with a laminate part including a plurality of functional devices with laser light while locating a light-converging point within the substrate, so as to form a modified region to become a start point for cutting within the substrate along a line to cut the substrate;

the method comprising the steps of:

forming a first modified region along a first line to cut for cutting the substrate and laminate part into a plurality of blocks; and

forming a second modified region along a second line to cut for cutting the blocks into a plurality of chips, each chip including at least one of the functional devices;

wherein the first modified region is more likely to cause the substrate to fracture than is the second modified region.

Claim 2 (Original): A laser processing method according to claim 1, further comprising the steps of:

attaching an expandable film to a rear face of the substrate formed with the first and second modified regions; and

expanding the expandable film, so as to start cutting the substrate and laminate part into the blocks from the first modified region acting as a start point, and then start cutting the blocks into the chips from the second modified region acting as a start point.

Claim 3 (Currently Amended): A laser processing method according to claim 1 [[or 2]], wherein the second line to cut passes between first lines to cut neighboring each other.

Claim 4 (Currently Amended): A laser processing method according to claim 1 [[or 2]], wherein the first and second lines to cut are substantially parallel to each other.

Claim 5 (Currently Amended): A laser processing method according to claim 1 [[or 2]], wherein the first and second lines to cut intersect each other.

Claim 6 (Currently Amended): A laser processing method according to one of claims

elaim 1 to 5 claim 1, wherein the substrate is a semiconductor substrate; and wherein the first and

second modified regions include a molten processed region.

Claim 7 (Currently Amended): A laser processing method according to one of claims 1

to 6 claim 1, wherein the first modified region in a part extending along the first line to cut in the

substrate has a forming density different from that of the second modified region in a part

extending along the second line to cut in the substrate, so as to make the first modified region

easier to generate a fracture in the substrate than is the second modified region.

Claim 8 (Currently Amended): A laser processing method according to one of claims 1

to 7 claim 1, wherein the first modified region in a part extending along the first line to cut in the

substrate has a size different from that of the second modified region in a part extending along

the second line to cut in the substrate, so as to make the first modified region easier to generate a

fracture in the substrate than is the second modified region.

Claim 9 (Currently Amended): A laser processing method according to one of claims 1

to 8 claim 1, wherein the first modified region in a part extending along the first line to cut in the

substrate is formed at a position different from a position where the second modified region is

formed in a part extending along the second line to cut in the substrate, so as to make the first

modified region easier to generate a fracture in the substrate than is the second modified region.

Claim 10 (Original): An object to be processed comprising a substrate and a laminate

part, formed on a front face of the substrate, including a plurality of functional devices;

the object further comprising:

a first modified region formed within the substrate along a first line to cut for cutting the

substrate and laminate into a plurality of blocks; and

a second modified region formed within the substrate along a second line to cut for

cutting the blocks into a plurality of chips, each chip including at least one of the functional

devices;

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wherein the first modified region is more likely to cause the substrate to fracture than is the second modified region.